

## Centre of Excellence in Renewable Energy (CERE) IIT(ISM), Dhanbad

Training: To trend highly qualified and innovative Personnel by Specialized training and knowledge in the field of color and wind onerny Through academic project Science & Engineering both)

Graduate & Master Students (Science & Engineering both)

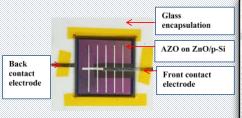
Short Torm Course (Postronbox Course) field of solar and Wind energy Through academic project Short Term Course | Refresher Course © Executives & Diploma Holders **Objectives** 

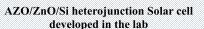


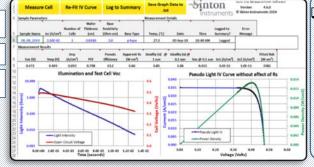




Two days "Training cum Awareness Program on Renewable Energy" for School Students under the program, 'Rashtriya Avishkar Abhiyan' (RAA) of MHRD, GoI, was successfully conducted during 27th -28th Feb, 2016 & 14th - 15th Sept., 2018.

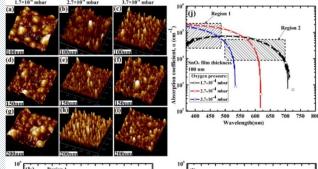






- □ Successfully achieved V<sub>oc</sub>~472mV (81% improvement)
- Undoped ZnO/Si heterojunction solar cell Highest reported V<sub>OC</sub>~260mV,

(Prog. Photovolt. Res. Appl. 2017; 1–9)



- 3 Successfully developed p-type SnO<sub>X</sub> thin film
  - Controlled oxygen pressure by using e-beam evaporation
    - ✓ Improved carrier concentration ~of ~7×10<sup>18</sup> /cc
    - √ Improved mobility 9 cm²/Vs
- Successfully achieved Good crystal quality and absorption coefficient
  - ■Optimised O<sub>2</sub> pressure and thickness of SnO<sub>x</sub> thin film
    - ✓ Good crystal quality and absorption coefficient

AFM 3D micrographs of SnO<sub>X</sub> film for different thicknesses grown at different O<sub>2</sub> pressures.



## Important Equipment/Facilities at (CERE), IIT(ISM), Dhanbad



Semiconductor Paramete Analyzer (with *I-V*, *C-V*, *C-F*)

Make: KEYSIGHT B1500A



Hot plate with magnetic stirrer (temp up to 350°C) Make: REMI



Solar Simulator & SMU Make: NCPRE, IIT Mumbai & Keithley



STYLUS Based Thickness profiler (Make: BRUKER DektakXT)



Converter (Multilevel) System Make: Hertz Power Control



WorkStation-2Nos. (20 core Processor RAM-196GB Make: FUJITSU



Fume Hood Make: LabGuard



Customized Dual Chamber PVD System for Thin Film Deposition [RF/DC Sputtering (3 confocal magnetron), Thermal, and E-beam

Evaporation]
Make: HHV Pvt. Co. Ltd.





Hall Effects Measurement System

(Assembled)
Magnetic field up to 1.5 Tesla



Muffle Cum Tube Furnace
(Rising rate up to 15°C/min,
Temp: up-to 1200°C
Under controlled gaseous
environment)
(Makey Anta Innovations (R))

(Make: Ants Innovations (P) Ltd)



Rapid Thermal Processor
(Rising rate (max) 80°C/sec.,
Temp: up-to 1200 °C
Under controlled gaseous
environment)

(Make: Ecopia RTP 1300)



Grid connected Wind emulator with Doubly Fed Induction Generator Make: Entuple Technology Pvt. Ltd.